

Docket No.: 55071-329

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
: Douglas VAN DEN BROEKE, et al. :  
Serial No.: : Group Art Unit:  
: Filed: January 14, 2004 : Examiner:  
: For: METHOD AND APPARATUS FOR PROVIDING OPTICAL PROXIMITY  
FEATURES TO A RETICLE PATTERN FOR DEEP SUB-WAVELENGTH OPTICAL  
LITHOGRAPHY

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

IN THE SPECIFICATION: